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Form PTO-1449

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

Docket Number	Application Number
7378/71294	09/883,406
Applicant	
OKAZAKI et al.	
Filing Date	**Group Art Unit**
June 19, 2001	

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROP.
SMC	5 3 0 6 7 4 4	04.1994	WOLFERSBERGER et al.			
	5 4 0 9 9 7 1	04/1995	WOLFERSVERGER et al.			
SMC	4 0 3 3 9 2 0	07/1977	ISOZAKI et al.			

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	Translation Yes	Translation No
SMC	WO 98/58912	12/1998	PCT			X	
	JP 6211950 V	08/1994	JAPAN			X	
	JP 5009247 V	01/1993	JAPAN			X	
	JP 51017922 ✓	02/1976	JAPAN			X	
SMC	JP 51023531 ✓	02/1976	JAPAN			X	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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EXAMINER	DATE CONSIDERED
Sayan McClellan	1/3/03

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	Translation Yes	Translation No
SMC	JP 2000/234044 ✓	08/2000	JAPAN			X	
SMC	JP 2000/234045 ✓	08/2000	JAPAN			X	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

SMC	✓RadTech Europe 95, Exhibit & Conference for Radiation Curing, September 24-27, 1995, in Maastricht/NL
SMC	✓H. Anderson & A. Hult, "Initiator-Free Photopolymerization of an Aliphatic Vinyl Ether-Maleimide Monomer, Dept. of Polymer Technology, Vol. 69, No. 865, February 1997

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EXAMINER [signature] DATE CONSIDERED 1/3/03

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